

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Samantha S. H. Tan  
Serial No. : 10/696,394  
Filed : October 28, 2003  
For : CLEANING PROCESSES FOR SILICON CARBIDE  
MATERIALS  
Examiner : Matthew J. Song  
Group Art Unit : 1792  
Customer No. : 41161  
Confirmation No. : 6372

Mail Stop: Petition  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PETITION FOR WITHDRAWAL FROM ISSUE (37 C.F.R. 1.313)**

**PETITION**

1. Applicant hereby petitions for the withdrawal of this application from issue.

**PATENT ISSUE FEE**

2. The issue fee for this case has been paid on February 13, 2009.

**REASON(S) FOR WITHDRAWAL REQUEST**

3. The reason for the request for withdrawal from issue is:

(a) for Request for Continued Examination to permit consideration of an information disclosure statement under § 1.97.

Further details as to the reason(s) for this withdrawal request are set forth below:

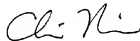
Applicants respectfully request withdrawal of the above identified application from issue so that the applicant may file a Request for Continued Examination to permit consideration of an information disclosure statement under 37 C.F.R. § 1.97. The references listed in the information disclosure statement to be considered were cited in a related, co-pending U.S. patent application.

**PETITION FEES**

4. The petition fee (37 C.F.R. 1.17(h)) is paid as follows:

Please charge \$130.00 to the Credit Card being submitted via EFS.

Respectfully submitted,

A handwritten signature in cursive script, appearing to read "Ch. Nicastrì".

Christopher Nicastrì  
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(914) 579-2200

Dated: March 6, 2009  
Hawthorne, New York